

Publikationen

- (2021): Safety cases for design-basis accidents in LWRs featuring passive systems. [InPress]. In: Nuclear Engineering and Design, no. Available online 26 February 2021. DOI: 10.1016/j.nucengdes.2021.111095.
- (2019): Vorrichtung zum Induktivladen eines Kraftfahrzeugs, Kraftfahrzeug.
- (2019): Method and device for detecting the commencement of opening of a nozzle needle.
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- (2017): Method and device for detecting commencement of opening of nozzle needle.
- (2016): Method and device for detecting the commencement of opening of a nozzle needle.
- (2016): Verfahren und Steuereinheit zur Detektion des Öffnungsbeginnes einer Düsennadel.
- (2015): [DE] Verfahren und Vorrichtung zur Detektion von Betriebszuständen eines elektromagnetisch angetriebenen Gerätes [EN] Method and device for detecting operating states of an electromagnetically driven
- (2015): [DE] Verfahren und Einrichtung zur Detektion des Öffnungsbeginnes einer Düsennadel [EN] Method and device for detecting the commencement of opening of a nozzle needle [FR] Procédé et dispositif de
- (2015): Verfahren und Einrichtung zur Detektion des Öffnungsbeginnes einer Düsennadel.
- (2015): Verfahren und Vorrichtung zur Detektion von Betriebszuständen eines elektromagnetisch angetriebenen Gerätes.
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- (1993): Deep proton irradiation of PMMA for a 3D integration of micro-optical components. In: Integrated Optics and Micro-Optics with Polymers, Wiesbaden.
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- (1992): Microoptical setup with microlenses and microprisms based on refractive optics. In: Proceedings of SPIE Vol. 1806: Optical Computing.
- (1992): A new monolithic integration method for microprisms, microbeamsplitters and microlenses in PMMA. In: Proceedings of the 8th Workshop on Optics in Computing.
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